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Mail Stop AMENDMENT  
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on December 18, 2007.

Michael S. Huppert  
name of person signing certification

December 18, 2007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 5135  
Atuhito MOCHIDA et al. : Attorney Docket No. 2003\_1798A  
Serial No. 10/730,982 : Group Art Unit 1725  
Filed December 10, 2003 : Examiner Kiley Shawn Stoner  
A METHOD OF MOUNTING A **Mail Stop: AF**

SEMICONDUCTOR LASER  
COMPONENT ON A SUBMOUNT

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### AMENDMENT AFTER FINAL

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 18, 2007, please amend the above-referenced U.S. patent application as follows: